

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Härle et al.
Serial No. : 10/813,530
Filed : March 29, 2004

Art Unit : 2818
Examiner : Chuong A. Luu
Confirmation No: 5329

Title : METHOD FOR FABRICATING A SEMICONDUCTOR COMPONENT BASED
ON A NITRIDE COMPOUND SEMICONDUCTOR

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**REPLY TO ACTION OF AUGUST 23, 2006
AND
STATEMENT OF THE SUBSTANCE OF THE INTERVIEW**

In reply to the Office Action of August 23, 2006, applicant submits the following
remarks: